Structural, magnetic, and transport properties of thin films of the Heusler alloy Co$_2$MnSi

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(Received 12 November 2003; accepted 10 February 2004)

Thin films of Co$_2$MnSi have been grown on a-plane sapphire substrates from three elemental targets by dc magnetron cosputtering. These films are single phase, have a strong (110) texture, and a saturation magnetization of 4.95 $\mu_B$/formula unit at 10 K. Films grown at the highest substrate temperature of 715 K showed the lowest resistivity (47 $\mu\Omega$ cm at 4.2 K) and the lowest coercivity (18 Oe). The spin polarization of the transport current was found to be of the order of 54% as determined by point contact Andreev reflection spectroscopy. A decrease in saturation magnetization with a decrease in film thickness and different transport behavior in thinner films indicate graded disorder in these films grown on nonlattice matched substrates. © 2004 American Institute of Physics. [DOI: 10.1063/1.1690868]

The growing interest in Heusler alloys is due to their predicted high spin polarization ($P$) (i.e., dominance of carriers of one spin orientation at the Fermi energy). Such materials could prove to be a useful source of spin to inject into semiconductors. Some Heusler alloys have been predicted to be half-metallic ferromagnets (HMFs), in which a band gap opens at the Fermi level ($E_F$) for one spin direction, leading to 100% spin polarized conduction electrons. There are two families of Heusler alloys: the half Heusler alloys which have compositions of the form XYZ and the full Heusler alloys, which have compositions of the form $X_2YZ$. Experimentally, the spin polarization of the transport current, $P_t$, of the HMF oxide CrO$_2$ has been measured by point contact Andreev reflection spectroscopy as 96%, but is disappointing for half-Heusler NiMnSb, with $P_t \approx 58\%$. It is important to identify the mechanisms that cause this half Heusler not to achieve its predicted 100% $P_t$ at the free surface. Three mechanisms have been identified: surface reconstruction and segregation, and interatomic disorder.

Co$_2$MnSi is a full Heusler alloy that has been predicted to be a HMF. It crystallizes in the $L2_1$ structure (space group $Fm\overline{3}m$), which consists of four interpenetrating face-centered-cubic (fcc) sublattices. This could be a very promising material for microelectronic devices: it is predicted to have a high Curie temperature for one spin direction, leading to 100% spin polarized conduction electrons. There are two families of Heusler alloys: the half Heusler alloys which have compositions of the form XYZ and the full Heusler alloys, which have compositions of the form $X_2YZ$. Experimentally, the spin polarization of the transport current, $P_t$, of the HMF oxide CrO$_2$ has been measured by point contact Andreev reflection spectroscopy as 96%, but is disappointing for half-Heusler NiMnSb, with $P_t \approx 58\%$. It is important to identify the mechanisms that cause this half Heusler not to achieve its predicted 100% $P_t$ at the free surface. Three mechanisms have been identified: surface reconstruction and segregation, and interatomic disorder.

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We have grown thin films of Co$_2$MnSi by dc magnetron cosputtering from three, elemental targets (as opposed to a single alloy target) in order to control the stoichiometry precisely, as well as to study off-stoichiometric compositions. In this letter we report on the transport properties and present transport spin polarization measurements carried out on thin films of this alloy. This study shows that optimized films have properties that are close to those of bulk single crystals.

Films were deposited from three, elemental dc magnetron targets arranged in a triangular configuration, onto an array of a-plane sapphire substrates located directly below the targets on a Ta strip heater. The base pressure of the deposition chamber was $2 \times 10^{-9}$ Torr and the argon pressure during the film deposition was 24 mTorr. The target–substrate distance varied between 111 and 116 mm (measured from the center of each target to the substrate position that gives the desired stoichiometry). This geometry enabled a range of compositions to be attained on the array of substrates, but small variation across each substrate (4 $\times$ 9 mm$^2$). The depositions were carried out at a range of substrate temperatures ($T_{sub}$) from 545 to 715 K, and a range of film thicknesses from 110 to 400 nm were deposited. Film thickness was determined by profilometry of a step formed on a masked substrate: the deposition rate was 0.10 nm/s. Film compositions were determined by energy dispersive x-ray analysis in a scanning electron microscope (SEM) with precision of 1.5%.

Structural characterization was performed by x-ray diffraction (XRD) and the XRD pattern of a 400 nm, stoichiometric film grown at $T_{sub}$ of 715 K is shown in Fig. 1. The film is single phase (within the resolution of the measurement) and all diffraction peaks can be attributed to the Co$_2$MnSi $L2_1$ structure. The film is polycrystalline with a strong (110) texture. Magnetic measurements carried out in a vibrating sample magnetometer and a superconducting quantum interference device magnetometer from room temperature...
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is shown in Fig. 2. These films are all stoichiometric and are

400 nm thick. \( \rho_{42K} \) decreases with an increase in \( T_{sub} \) which is most likely due to an increase in grain size and hence a reduction in grain boundary scattering. As \( T_{sub} \) increases from 545 to 715 K the surface features (which reflect the grain size) observed in a field emission gun SEM increase from about 70 to 130 nm, and \( \rho_{42K} \) is halved (102–47 \( \mu \Omega \) cm).

For a stoichiometric film grown at \( T_{sub} \) of 715 K, the \( \rho–T \) curve was fitted: in the temperature range of 295–100 K, \( \rho \) decreased linearly with the temperature. This differs from in previous reports\(^{1,4,15} \) in which a \( T^n \) dependence was observed, where \( 1.3<n<1.5 \). However, not all our films show linear behavior and, as the compositions become more off stoichiometric, the nonlinearity becomes more pronounced. Below 100 K (for the stoichiometric film grown at 715 K) there is a change in the resistivity behavior, and \( T^2 + T^{9/2} \) behavior is observed. The \( T^{9/2} \) term is attributed to two-magnon scattering, which is the first available magnetic

scattering process for a HMF. The \( T^2 \) term results either from one-magnon scattering or from electron–electron scattering. In a HMF, one-magnon scattering cannot occur at low temperature because there are no states at \( E_F \) into which the electron can be scattered. Therefore, if these films are truly HMF, then the \( T^2 \) term must arise from electron–electron scattering. Below about 20 K, \( \rho \) shows no temperature dependence, which is in agreement with the findings of Ambrose et al.\(^{14} \) but not with other reports.\(^{15–17} \) The different behaviors observed could be material dependent, but are also dependent upon fabrication parameters (different behavior observed even for the same alloy), since crystallography and microstructure will affect the \( \rho–T \) behavior.

\( H_c \) also decreases with \( T_{sub} \) as shown in Fig. 2, where an increase in \( T_{sub} \) from 545 to 715 K results in a reduction in \( H_c \) by a factor of 3 (\( M_s \) is a constant in these films). The change in \( H_c \) is crystallographic and/or microstructural in origin: both the grain size and degree of (110) texturing increase as \( T_{sub} \) increases. \( H_c \) correlates strongly with the change in film texture (inset of Fig. 2). As \( T_{sub} \) increases, the (422) peak decreases relative to the (220) peak and \( H_c \) decreases.

Figure 3 shows the dependence of \( \rho_{42K} \) and \( M_s \) on the film thickness, \( d \), for a series of stoichiometric films grown at \( T_{sub} \) of 602 K. \( \rho_{42K} \) decreases with an increase in film thickness. This can be attributed to the reduction in grain boundary scattering: the surface feature size increases from about 20 to 70 nm as the film thickness increases from 110 to 300 nm. Thinner films also show a stronger (110) texture. \( M_s \) decreases by about 25% as the film thickness decreases from 400 to 110 nm. This indicates that thinner films are disordered, due to the absence of lattice matching between the film and substrate.

A change in the \( \rho–T \) curves is also observed in the above series of films as the film thickness decreases: an upturn in the resistivity at low temperatures is present for the 164 nm film and becomes more pronounced in the 110 nm film (Fig. 4). This upturn has been observed in Ni\(_2\)MnGe at 20 K by Lund et al.\(^{16} \) and in Co\(_2\)MnSi at 40 K by Geiersbach et al.\(^{10} \) We have also observed this phenomenon in off-stoichiometric films.\(^{18} \) The upturn is interpreted as weak localization\(^{16} \) due to electron–electron interaction effects, arising in this case from disordered material, consistent with the decrease in \( M_s \).

\( \rho \) was measured by point contact Andreev reflection\(^{2,19} \).
between Nb cut tips and the Heusler film at 4.2 K. The normalized conductance versus voltage curves were fitted to the Mazin model in the ballistic regime,\textsuperscript{19} to determine $P_t$ and the effective tunnel barrier height, $Z$. The barrier may arise due to the combined effects of surface contamination or disorder, Fermi velocity mismatch in the two materials, and interface scattering. Experimentally, $Z$ can be varied to a certain extent by changing the tip pressure ($Z=0$ corresponds to a clean interface and is obtained at higher pressure). The inset shows the variation in $P_t$ with $Z$ for a stoichiometric, 400 nm film grown at 715 K (closed squares) and the 110 nm film (open square).

In summary, we have grown Co$_2$MnSi from three elemental targets on $\alpha$-plane sapphire substrates by dc magnetron cosputtering and have obtained highly textured, single phase films without the use of a seed layer.\textsuperscript{10,11} The stoichiometric, 400 nm films had the bulk value of $M_s$ and films grown at the highest $T_{\text{sub}}$, showed the lowest $\rho$ and $H_c$. The $P_t$ of a 400 nm film grown at this deposition temperature was 54%. A decrease in $M_s$ with decreasing film thickness and the different transport behavior of thinner films indicate graded disorder, which is significant even at a thickness of 110 nm. Increased interface scattering in disordered magnetic films is an interesting independent observation. By growing on GaAs, which has a similar lattice parameter to Co$_2$MnSi, it is expected that this disordered region will be confined to the first few atomic layers.

This work was supported by the Engineering and Physical Sciences Research Council, UK.

\textsuperscript{17}J. S. Moodera and D. M. Mootoo, J. Appl. Phys. \textbf{76}, 6101 (1994).